Wednesday Morning, November 8, 2023

Applied Surface Science Division

Room B117-119 - Session

AS+2D+CA+EL+EM+MS+NS+SE+SS+TF-WeM

Multi-Modal & Multi-Dimensional Analysis

Moderators: Gustavo Trindade, National Physical Laboratory, UK, Paul Mack, Thermo Fisher Scientific, UK, Tim Nunney, Thermo Fisher Scientific, UK

8:00am AS+2D+CA+EL+EM+MS+NS+SE+SS+TF-WeM-1 Growth and Characterization of Large-Area 2D Materials, Glenn Jernigan, US Naval Research Laboratory INVITED

Nothing could be more coupled than Growth and Characterization. When two dimensional (2D) materials appeared on the radar of the scientific community (with the amazing properties of graphene), it was immediately obvious that large area samples would be needed. Exfoliating flakes was insufficient for the demands of scientific studies, in addition to not being viable should a commercial application be developed. Thus, the search began for growth methods to produce large-area 2D materials for large scale testing and development.

The Naval Research Laboratory has, over the past 15 years, pursued research programs in producing large areas of graphene, transition metal dichalcogenides (TMDs), boron nitride (BN), and other 2D materials. In every one of those programs, they began with surface analysis of composition, chemistry, and morphology of the grown films. The uniquely sensitive nature of x-ray and ultraviolet photoelectron spectroscopy (XPS and UPS) and scanning tunneling and atomic force microscopy (STM and AFM) to 2D materials was necessary to measure the electrical, chemical, and physical properties obtained in the large area films and to understand what was observed in the exfoliated flakes. The production of large areas allowed "mass-scale" optical and electrical characterization, which then became a feedback loop in the search for new and interesting properties and relevant applications. In this presentation, I will show how we developed large-area graphene, by both epitaxial growth and chemical vapor deposition methods, TMDs, and other 2D materials for characterization and device utilization.

8:40am AS+2D+CA+EL+EM+MS+NS+SE+SS+TF-WeM-3 Using a Correlative Approach with XPS & SEM to Measure Functionalized Fabrics for Antimicrobial Applications, *Tim Nunney*, *H. Tseng*, Thermo Fisher Scientific, UK; *D. Marković*, *M. Radetić*, University of Belgrade, Serbia

Medical textiles are an indispensable component for a wide range of hygienic and healthcare products, such as disposable surgical gowns and masks, or personal protection equipment, with opportunities to provide further protection by engineering textiles with suitable medical finishing. While antibiotics are considered a viable option for their efficiency in treating bacterial infections, their abuse can result in adverse effects, e.g., bacteria resistance. Nanocomposites have emerged as a promising alternative to antibiotics, as the large surface-to-volume ratio and high activity helps attain the targeted antimicrobial efficiency by using tiny amounts of nanocomposites, and their biocompatibility and scalability are particularly advantageous for medical applications [1]. Thus, developing processing methods to integrate nanocomposites in the fabrics is essential for exploiting their properties for medical textiles.

In this study, polypropylene fabrics, alginate and copper oxides, were selected to develop novel antimicrobial nanocomposites based on various surface treatments, i.e. corona discharge and alginate impregnation, which led to improved fabrics hydrophilicity with functional groups introduced as binding sites for Cu(II), a precursor that formed Cu nanoparticles when reacted with reducing agents, i.e. NaBH4 and ascorbic acid. The composition of the fabrics after being treated with corona discharge and impregnation observed by XPS indicates the materials formed mainly consisted of C and O, attributed to the presence of a thin, hydrophilic layer and alginate, respectively, consistent with depth profiling measurements. Following Cu reduction, XPS mapping of the fabrics finds that, reacting with ascorbic acid resulted in formation of nanocomposites containing a mixture of Cu and Cu (II) oxides across the surface, which could be visualised by using SEM in the same locations. Excellent anti-microbial activity against Gram-negative bacteria E. coli, Grampositive bacteria S. aureus and yeast C. albicans was observed for the treated fabrics[2]. This result not only demonstrates a cleaner, and healthier approach for developing novel nanocomposites, but more importantly highlights the role of surface

techniques in uncovering challenges in designing and engineering functional textiles.

References:

 D. Marković, J. Ašanin, T. Nunney, Ž. Radovanović, M. Radoičić, M. Mitrić, D. Mišić, M. Radetić, Fibers. Polym., 20, 2317–2325 (2019)

[2] D. Marković, H.-H. Tseng, T. Nunney, M. Radoičić, T. Ilic-Tomic, M. Radetić, Appl. Surf. Sci., 527, 146829, (2020)

9:00am AS+2D+CA+EL+EM+MS+NS+SE+SS+TF-WeM-4 Multi-Modal Analysis in Photoelectron Spectroscopy: From High-Resolution Imaging to Operando Experiments, Olivier Renault, CEA-Leti, France; A. Benayad, CEA, France; N. Gauthier, CEA-Leti, France; R. Charvier, ST Microelectronics, France; E. Martinez, CEA-Leti, France

Over the past years, the field of surface and interface analysis has been greatly expanded by new developments made possible by lab-scale instruments enabling higher excitation energies. These new developments are directly serving technological advances especially in the area of technologies in renewable energies and nanoelectronics, which are adressing more and more complex system requiring to go beyond traditional ways of characterizing surfaces and interfaces. Different dimensions are to be explored in multi-modal surface analysis : the depth dimension, the lateral dimension, and the dynamic dimension.

After a short review of some of the achievements towards enhancing the depth dimension by lab-scale hard X-ray photoelectron spectroscopy (HAXPES) and the lateral dimension using X-ray PEEM, we will present different application cases of *operando* HAXPES. Here, the material is analyzed as being part of a device operated *in situ* during the experiment, in conditions that are as close as possible to the final applications and where the interfaces can be studied in dynamic conditions. We will first review some results of *operando* HAXPES on resistive memories obtained with synchrotron radiation [1, 2] before presenting various lab-scale experiments [3, 4] and the current limitations to such approaches.

[1]B. Meunier, E. Martinez, O. Renault et al. J. Appl. Phys. **126**, 225302 (2019).

[2]B. Meunier, E. Martinez, O. Renault et al., ACS Appl. Electron. Mater. 3 (12), 5555–5562 (2021).

[3]O. Renault et al., Faraday Disc. 236, 288-310 (2022).

[4]A. Benayad et al., J. Phys. Chem. A 2021, 125, 4, 1069-81.

9:20am AS+2D+CA+EL+EM+MS+NS+SE+SS+TF-WeM-5 Multi-Modal Analyses of Ultrasonic-Spray-Deposited Ultrathin Organic Bathocuproine Films, J. Chen, Juliet Risner-Jamtgaard, T. Colburn, A. Vailionis, A. Barnum, M. Golding, Stanford University; K. Artyushkova, Physical Electronics; R. Dauskardt, Stanford University

Bathocuproine (BCP) is a small organic molecule that is typically used as an ultrathin hole blocking interlayer (< 10 nm thickness) in organic solar cells and perovskite solar cells. The film is typically deposited via low-throughput vacuum thermal evaporation with an *in-situ* Quartz Crystal Monitor to measure film thickness. Open-air ultrasonic spray deposition for low-cost and large-scale deposition is an attractive alternative method for solution processing of BCP films, but the process lacks a comparable *in-situ* metrology. Given that the BCP film is transparent to visible light and ultrathin, it is important to utilize a multi-modal approach to evaluate optoelectronic and physical properties of the sprayed film.

A suite of characterization techniques that span a range of equipment complexity, measurement time, and measurement sensitivity are used to analyze the BCP films. We begin by demonstrating the limitations of the singular ellipsometry model¹ for BCP found in literature and motivate a need to rely on other techniques. Multi-modal analyses including X-Ray Reflectivity, Angle-Resolved X-ray Photon Spectroscopy (AR-XPS), Auger Spectroscopy, Scanning Electron Microscopy, and Transmission Electron Microscopy with EELS are then performed on the sprayed BCP film. The advantages and disadvantages of each characterization technique are compared and discussed. We conclude that AR-XPS provides the most distinctive determination of individual layer thicknesses for a sample architecture consisting of silicon substrate/native SiO_x/BCP across the applicable range of AR-XPS from ~ 1-10 nm.

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^[1]Liu, Z.T., *et al*. The characterization of the optical functions of BCP and CBP thin films by spectroscopic ellipsometry. *Synthetic Materials*. 150(2):159-163. (2005)

9:40am AS+2D+CA+EL+EM+MS+NS+SE+SS+TF-WeM-6 Combinatorial Synthesis and High-Throughput Characterization of Pt-Au Thin Films Fabricated by Confocal Magnetron Sputter Deposition, David Adams, R. Kothari, M. Kalaswad, C. Sobczak, J. Custer, S. Addamane, M. Jain, E. Fowler, F. DelRio, M. Rodriguez, R. Dingreville, B. Boyce, Sandia National Laboratories

A few binary metal alloys are predicted to form thermally stable, compositionally segregated structures owing to the thermodynamic preference for minority species to collect and remain at grain boundaries established within the solid.(J.R. Trelewicz et al., PRB, 2009) When produced as a nanocrystalline thin film, these stable structures afford the potential to maintain excellent mechanical properties (e.g., high hardness) even after annealing to elevated temperature. Indeed, several systems, including Pt.₉Au.₁ thin films, are reported to develop thermally-stabilized, hard, nanocrystalline structures attributed to solute segregation at grain boundaries.(P. Lu et al., Materialia, 2019)

Future studies that seek optimal stoichiometry and/or preferred synthesis processes require access to a wide range of composition as well as an ability to vary key deposition parameters. Toward this end, our team reports on the challenges and the benefits of combinatorial synthesis for expediting the discovery of improved binary metal thin films. Our study utilized confocal sputter deposition wherein Pt and Au targets were individually sputtered via pulsed DC magnetron methods. Substrates (150 mm diameter wafers) were fixed in order to gain access to a wide compositional range for each deposition. The sputter power and cathode tilt orientation were then varied in subsequent depositions to access the nearly full binary metal compositional range. The binary collision Monte Carlo program SiMTra (D. Depla et al., Thin Solid Films 2012), which simulates the transport of sputtered atoms within the process gas, helped guide the selection of these process parameters in order to achieve compositional goals in relatively few depositions. Notably, the binary compositions predicted by SiMTra closely matched (within a few molar %) the measured compositions determined by Wavelength Dispersive Spectroscopy completed in 112 different areas across each wafer. The various combinatorial Pt-Au films were further characterized by highthroughput Atomic Force Microscopy, automated X-ray Diffraction, fast Xray Reflectivity, mapping four-point probe sheet resistance, and automated nanoindentation. These studies reveal how hardness, modulus, film density, crystal texture, and resistivity of combinatorial films varied with composition as well the atomistics of film deposition. Attempts to correlate key film characteristics with the kinetic energies and incident angles of arriving metal species (estimated by SiMTra) are discussed with a goal of improving fabrication processes.

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11:00am AS+2D+CA+EL+EM+MS+NS+SE+SS+TF-WeM-10 Optical and X-Ray Characterization and Metrology of Si/Si(1-X)Ge(X) Nanoscale Superlattice Film Stacks and Structures, Alain Diebold, SUNY Polytechnic Institute INVITED

As traditional scaling of transistors comes to end, transistor channels and capacitors are being stacked to form new 3D transistor and memory devices.Many of these devices are fabricated using films stacks consisting of multiple Si/Si(1-x)Gex layers known as superlattices which must be fabricated with near atomic precision. In this talk, we discuss how Optical and X-Ray methods are used to measure the feature shape and dimensions of these structures. The use of X-Ray methods such as ω -2 θ scans and reciprocal space maps provide layer thickness and stress characterization. We will use simulations to show how a buried layer with a different thickness or Ge concentration alters the data. Recent electron microscopy studies have quantified the stress at the interfaces of these superlattices.We will also discuss how Mueller Matrix spectroscopic ellipsometry (MMSE) based scatterometry is used to measure feature shape and dimension for the nanowire/nanosheet structures used to fabricate nanosheet transistors and eventually 3D DRAM. The starting point for optical scatterometry is determining the optical properties of stressed pseudomorphic Si(1-x)Gex.MMSE can be extended into the infra-red and into the EUV.In addition, small angle X-Ray scattering has been adapted into a method knows as CDSAXS which can be used to characterize these structures. This talk will be an overview of these methods.

11:40am AS+2D+CA+EL+EM+MS+NS+SE+SS+TF-WeM-12 Non-Destructive Depth Differentiated Analysis of Surfaces Using Ion Scattering Spectroscopy (ISS), XPS and HAXPES, Paul Mack, Thermo Fisher Scientific, UK

Recently there has been renewed interest in probing deeper into surfaces using HAXPES in addition to the more surface sensitive (soft X-ray) XPS. On modern XPS systems, with high sensitivity, the total sampling depth may be somewhere between 10nm and 15nm but HAXPES enables the analyst to look deeper, without having to destructively sputter the surface with ions. For a complementary, more comprehensive analysis, XPS and HAXPES can be combined with Ion Scattering Spectroscopy (ISS). ISS is far more surface sensitive than XPS, typically being thought of as a technique to analyse the top monolayer of a sample for elemental information.

In this work, the combination of XPS, HAXPES and ISS on a single tool has been used to give a non-destructive depth differentiated analysis of a range of samples, including a perovskite and an industrially relevant material containing multiple transition metals. The combination of all three techniques provides insight into the depth distributions of elements and chemical states, from the top monolayer to beyond 20nm into the surface.

AS+2D+CA+EL+EM+MS+NS+SE+SS+TF-WeM-13 12:00pm Towards Measurement of Molecular Shapes Using OrbiSIMS, Gustavo F. Trindade, J. Vorng, A. Eyres, I. Gilmore, National Physical Laboratory, UK An OrbiSIMS [1] instrument features a dual analyser configuration with a time-of-flight (ToF) mass spectrometer (MS) and an Orbitrap[™] MS, which confer advantages of speed and high-performance mass spectrometry, respectively. The ability to combine the MS performance usually found in a state-of-the-art proteomics and metabolomics MS with 3D imaging at the microscale and from nanolayers of <10 nm of material has proved popular in a broad field of application from organic electronics to drug discovery. For secondary ions to be efficiently transferred to the Orbitrap analyser, the sample is biased by a target voltage V_T necessary to match the acceptance window of the Orbitrap. Furthermore, the ions kinetic energy from the SIMS collision process must be reduced. Therefore, in the OrbiSIMS, a transfer system with helium gas at a pressure P_{He} slows the ions and reduces their kinetic energy distribution through inelastic collisions with gas atoms. Usually, an Orbitrap is used with an ambient pressure ion source and so here an extra gas flow of nitrogen is introduced that leads to an increase of pressure P_{N2} to compensate.

We conducted a systematic assessment of V_T and P_{He} and P_{N2} on the transmitted secondary ion intensities [2] and revealed a complex behaviour, indicating the possibility for additional separation of ions based on their shape, stability, and kinetics of formation. We showed that the V_T for maximum transmission of secondary ions will not be the same for all molecules of the same material and that sometimes multiple maxima exist. Here, we present recent progress towards the understanding of these phenomena and how we are leveraging it to measure molecular shape by using reference trisaccharides raffinose, maltrosiose and melozitose [3].

[1] M. K. Passarelli *et al.*, "The 3D OrbiSIMS—label-free metabolic imaging with subcellular lateral resolution and high mass-resolving power," *Nat. Methods*, no. november, p. nmeth.4504, 2017, doi: 10.1038/nmeth.4504.

[2] L. Matjacic *et al.*, "OrbiSIMS metrology part I: Optimisation of the target potential and collision cell pressure," *Surf. Interface Anal.*, no. November 2021, pp. 1–10, 2021, doi: 10.1002/sia.7058.

[3] G.F. Trindade *et al.*, In preparation.

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